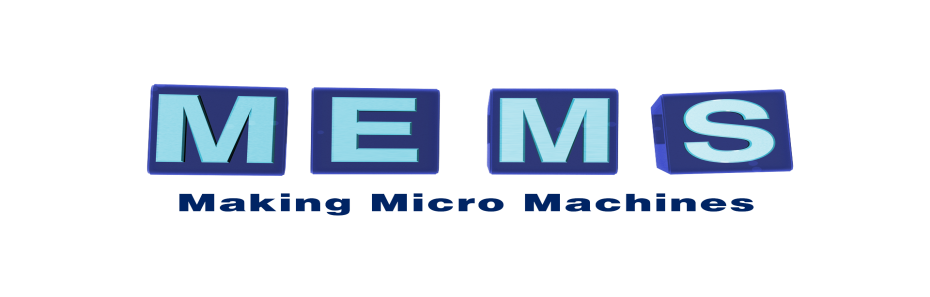
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|  | **Southwest Center for Microsystems Education (SCME)**  **University of New Mexico**  **Optical MEMS Activity 2**  **Shareable Content Object (SCO)**  **This SCO supports the film by Silicon Run Productions:**  mem_title  **and is part of the**  **MEMS: Making Micro Machines Learning Module**  Target audiences: High School, Community College, Industry Technologists.  Support for this work was provided by the National Science Foundation's Advanced Technological Education (ATE) Program through Grants #DUE 0830384 and 0902411.  Any opinions, findings and conclusions or recommendations expressed in this material are those of the authors and creators, and do not necessarily reflect the views of the National Science Foundation.  Copyright 2009 - 2011 by the Southwest Center for Microsystems Education  and  The Regents of the University of New Mexico  Southwest Center for Microsystems Education (SCME)  800 Bradbury Drive SE, Suite 235  Albuquerque, NM 87106-4346  Phone: 505-272-7150  Website: [www.scme-nm.org](http://www.scme-nm.org) email contact: [mpleil@unm.edu](mailto:mpleil@unm.edu)  MEMS Film Website: [www.siliconrun.com](http://www.siliconrun.com) |  |  |



**Activity 1 - Microfluidics**

**Participant Guide**

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| Description and Estimated Time to Complete |
| *MEMS: Making Micro Machines Learning Module supports the film of the same name produced and directed by Ruth Carranza of Silicon Run Production. The film introduces MEMS (microelectromechanical systems), applications, fabrication, and design. This learning module provides activities to encourage you to delve deeper into the topics introduced in the film and to demonstrate your understanding of the terminology and general concepts of MEMS.*  This is the first of three activities in the learning module. This activity is designed to be completed after viewing the first part of the film: Microfluidics.  This activity consists of two parts:   * A **crossword puzzle** that tests your knowledge of the terminology and acronyms associated with MEMS applications and microfluidics, and * **Post-activity questions** that ask you to demonstrate your understanding of microfluidics and microfluidics fabrication.   Estimated Time to Complete  Allow at least 30 minutes to complete this activity. |

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| Introduction |
| Microfluidics is a multidisciplinary field that deals with the behavior of fluids in the microliter and smaller volume range. As volume decreases, the ratio of surface area to volume increases. As a result, the surface properties of fluids become dominant as one deals with smaller and smaller volumes. Therefore, the interaction of the fluid with the walls of micro chamber and channel surfaces dominates fluid behavior. The surface area to volume ratio of a 100μm per side cube is 0.06cm-1 and that of a 10μm per side cube is 0.6cm-1, ten times larger! Therefore, a fluid will cool or heat much faster in a smaller chamber.    This image is of an array of microfluidic channels and reservoirs created at the University of California, Berkeley. The width of the reservoirs are smaller than the diameter of a strain of hair (60 to 100 μm). Think about how small the microchannels are!  *[C. Ionescu-Zanetti, R. M. Shaw, J. Seo, Y. Jan, L. Y. Jan, and L. P. Lee (PNAS, 2005). Printed with permission by Luke Lee, Dept. of Bioengineering, UC-Berkeley)* |

Fluid flow is enhanced as channels decrease in size due to surface tension effects, called capillary action. The microfluidics field includes the science of these behaviors as well as the technology used to incorporate and leverage the small-scale behavior of fluids. Microfluidic systems are found in many application areas such as biomedical, molecular biology, consumer products, filtration and purification systems, environmental testing and micropumps.

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| The film MEMS: Making Micro Machines discusses the fabrication of a microfluidic device called a thermal inkjet printhead, also referred to as a bubblejet printhead. This printhead is a microfluidic device that uses the capillary effect of a fluid in a microchannel as well as the rapid heating of a fluid (due to high surface area to volume ratio) to produce a fast, high resolution printhead.  A thermal inkjet printhead is a non-mechanical micropump, meaning it has no moving parts. In this pump, heat is applied locally to a microchamber filled with ink. Very quickly (0.0001 seconds) the ink evaporates forming a bubble. The bubble forces a tiny droplet of ink out through the micro nozzle and onto the paper. When the heat is removed, the bubble collapses bringing more ink into the chamber through capillary action. Surface tension prevents the ink from flowing out of the nozzle once the chamber is full.1  Let's take a more detailed look at how this thermal inkjet printhead works. The process of pumping a droplet of ink from an inkjet printhead (micropump) is a multiple stage process. (Refer to the diagram and film as you follow this process.) |
| DiagramInkJetPrinterNBG7_08   1. The microchannel fills with ink. Because the microchannel’s dimensions are so small (approximately a micrometer in diameter) the liquid automatically fills the microchannel due to capillary action. 2. An electrical voltage is applied to the heater (a resistive element). Current through the heater creates enough heat energy to evaporate the ink in less than 0.0001 seconds. 3. Evaporation of the ink forms a bubble. 4. As the bubble forms it forces the ink through the nozzle and out of the channel. 5. The ink is sprayed onto the paper below. 6. The voltage is removed, the heater turns off, and the bubble collapses. 7. The microchannel automatically refills due to capillary action. |
| To make an inkjet printhead, "hundreds of these microscopic MEMS devices are typically fabricated in pairs of columns that surround an ink supply manifold."2 Some of the newest printers produce droplets as small as 5 picoliters and can print up to 9 pages per minute in full color (14 pages in black and white).3 The first part of the film MEMS: Making Micro Machines covers the fabrication of these inkjet printheads. |
| Activity Objectives and Outcomes |
| Activity Objectives   * Identify the related terms or acronyms associated with definitions related to MEMS, MEMS applications, microfluidics and microfluidics fabrication. * Demonstrate your understanding of microfluidics and microfluidics fabrication by correctly answering the Post-Activity questions. |
| Resources   * MEMS: Making Micro Machines, an overview of microelectromechanical systems, produced and directed by Ruth Carranza of Silicon Run Production. 2009. * "MEMS Applications". Southwest Center for Microsystems Education (SCME). 2009. * "Photolithograpy". Southwest Center for Microsystems Education (SCME). 2009. * "Deposition". Southwest Center for Microsystems Education (SCME). 2009. |
| Documentation   1. Completed Crossword Puzzle 2. Questions and Answers to the Post-Activity Questions |
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| Activity 1: Microfluidics Crossword Puzzle  Complete the crossword puzzle using the clues on the following page. |
| **microfluidics** |
| **Across**  1. MEMS used to stabilize the image of a camcorder or the effect of impact on a football helmet.  4. Acronym for Microelectromechanical Systems.  6. A quartz plate that contains a pattern and is used for the exposed step in photolithography.  8. In CMOS fabrication the metal layer is used as a(n) \_\_\_\_\_\_\_\_\_\_.  9. In a thermal inkjet print head, the heater vaporizes ink to form a \_\_\_\_\_\_\_.  12. Acronym for the optical MEMS that consists of an array of millions of digital micromirrors.  13. The thermo component that is used as a heater in an inkjet printhead.  17. A micro-\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_\_ is a trench between two rows of nozzles in an inkjet printhead.  18. Acronym for chemical vapor deposition.  21. In a MEMS, the type of components that convert information to and from digital.  22. The fabrication process that removes select material from the surface layer. Process can be wet or dry.  23. In CMOS manufacturing the silicon dioxide layer can be used as a(n) \_\_\_\_\_\_\_\_\_\_\_.  **Down**  2. In an inkjet printhead, \_\_\_\_\_\_\_\_\_\_\_\_ action is the property of microfluids that refills the microchannels.  3. Common term for equipment that moves objects such as wafers from one place to another or one stage of the process to another (pick and place).  4. The study of the behavior of small volume fluids.  5. Acronym for scanning electron microscope.  6. In MEMS, the type of component that “moves” something.  7. A fabrication process that deposits metal layers using a plasma and ion bombardment.  9. A micromachining process that etches into the substrate (bulk, surface or LIGA).  10. A soft \_\_\_\_\_\_ evaporates solvents from the photoresist.  11. Micromachining process that etches layers of thin films (bulk, surface or LIGA).  14. The CVD process that deposits a silicon dioxide thin film using a vaporized liquid that contains silicate is called \_\_\_\_\_\_\_\_\_\_.  15. A MEMS device that moves clinical lab testing out of the laboratory and into the field.  16. A fabrication process that deposits a thin film on the wafer’s surface.  17. Photolithography step that spins resist onto the wafer.  19. Photolithography process that removes the exposed resist.  20. A \_\_\_\_\_\_\_\_\_\_\_\_ of ionized chlorine based gases and inert gases is used to etch metal. |
| Post-Activity Questions |
| 1. What is microfluidics? 2. Name three applications of microfluidics. 3. Briefly discuss two challenges that engineering might face in the design and fabrication of microfluidic devices. 4. Create a block diagram of the photolithography process showing the steps as presented in the MEMS film. 5. Sketch and describe how an inkjet microsystem works. |

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| Summary |
| Microfluidics is a multidisciplinary field that deals with the behavior of fluids in the micro, nano and even picoliter scales. The behavior of fluids in these scales can differ from those of larger volumes. The design and fabrication of microfluidic devices must address these differences and create effective solutions. The manufacturing of an inkjet print head is an excellent example of how fluid behavior at these small scales is applied through microsystems fabrication technology in creating a highly effective consumer product. |
| References |
| 1. "Micropumps Overview". Southwest Center for Microsystems Education. 2009. 2. MEMS: Making Micro Machines, an overview of microelectromechanical systems, produced and directed by Ruth Carranza of Silicon Run Production. 3. Canon Bubblejet S520. High speed, high quality printer for the office. |

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| *Support for this work was provided by the National Science Foundation's Advanced Technological Education (ATE) Program through Grants. For more learning modules related to microtechnology, visit the SCME website (*[*http://scme-nm.org*](http://scme-nm.org)*).* |